

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10711416	DORIS ET AL.
	<b>Examiner</b>	<b>Art Unit</b>
	Wai-Sing Louie	2814

### SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
438	164	9/21/06	MDH
257	335	9/21/06	MDH
257	67, 347, 351	12/18/07	WSL
438	149,154,157	12/18/07	WSL

### SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
wafer bonding, through hole, epitaxial growth, crystal orientation, buried oxide layer, oxygen implanting, annealing	12/18/07	WSL

### INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
438	149,154,157	12/18/07	WSL